



DOCKET NO: VSEA 16-99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Grant Kenji Larsen
Serial No: 09/676,548
Confirmation No: 2719
Filed: September 29, 2000
For: SURFACE STRUCTURE AND METHOD OF MAKING, AND
ELECTROSTATIC WAFER CLAMP INCORPORATING
SURFACE STRUCTURE
Examiner: Stephen W. Jackson
Art Unit: 2836

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 20th day of January, 2004.


Cheryl Purcell

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

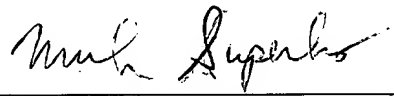
Petition for Extension of Time

A three-month extension of time to January 20, 2004 (Monday after Holiday) is requested for response to the Examiner's Office Action of September 17, 2003.

The extension fee of \$950.00 may be charged to deposit account No. 50-0896. If the amount is insufficient, please charge deposit account No. 50-0896. A duplicate of this Petition is enclosed.

01/26/2004 YPOLITE1 00000092 500896 09676548
02 FC:1253 950.00 DA

Respectfully submitted,
Grant Kenji Larsen, Applicant

By: 
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